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Re: U.S. Patent Application Serial No. 09/575,551

Entitled: Semiconductor Processing System With Wafer Container

Docking And Loading Station

Applicant(s): Raymon F. Thompson et al.

Filed: May 22, 2000

Art Unit 3652

Perkins Coie Ref. No.: 54008.8009.US02 (P97-0041US3)

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Atty Dkt. No.: 54008.8009.US02

U.S. Patent Application S/N: 09/575,551 Atty. Dkt. No. 54008.8009.US02

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I hereby certify that the (1) Request for Continued Examination (RCE) Transmittal; (2) Amendment in Second Request for Continuing Examination Following Decision on Appeal; and (3) Form PTO/SB/08A (formerly known as Form PTO-1449) (along with any pages referred to as being attached or enclosed) are being facsimile transmitted to the United States Patent and Trademark Office, Fax No. (703) 305-7687, on August 19, 2003.

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